Application Note: 50808

Detectors for Fourier Transform Spectroscopy

Key Words

- Detector
- FT-IR
- Responsivity
- Sampling Beam Geometry
- Specific
 Detectivity

Thermo Scientific FT-IR spectrometers can be configured to meet your need to produce the highest performance spectral data for a wide variety of applications. Optimization for each application requires the selection of specific system components – source, optics, electronics, interferometer, beamsplitter, and detector – to produce the best quality spectrum. Of these components, the detector is key, as it can be matched uniquely to specific applications. The choice of the ideal detector for spectral measurement is dependent upon many factors, including:

- Sensitivity
- Spectral range of the measurement
- Sampling beam geometry
- Temporal resolution of the data collection
- Spectral resolution
- Response time

This note will describe the unique features of detectors for vibrational spectroscopy, focusing primarily on Fourier transform infrared (FT-IR). It will help guide the choice for the ideal detector for specific applications.

High throughput (greater than 20% of IR beam reaching the IR detector) and static experiments are generally run utilizing a thermal detector, such as deuterated, L-alanine doped triglycine sulfate (DLaTGS), because it gives full, specific detectivity (D*) in high-flux environments. From an applications perspective, the DLaTGS detector provides linear response over a wide range of FT-IR throughput, which is beneficial in qualitative and quantitative FT-IR sampling. Thermal detectors are generally less effective for kinetic measurements because their signal is inversely proportional to data collection speed. Low-throughput experiments (less than 20% of IR beam reaching the detector) benefit from the use of a quantum detector, such as the mercuric cadmium telluride (MCT) detector. High MCT sensitivity yields good IR signal in a low-flux measurement. Furthermore, the MCT detector exhibits a relatively constant signal versus data-collection speed and is, therefore, ideal for kinetic measurements. A limitation of MCT detectors is that they lose responsivity and D*at high throughput. From the applications perspective, this means that in high-throughput applications, we must limit

the beam energy reaching the MCT detector to prevent saturation, where the detector responds with a non-linear signal. Limiting the beam energy can be done by using neutral density filters, or optical screens.

Vibrational spectroscopy detector specifications are listed in Table 1. DLaTGS is a high-performance element which provides higher sensitivity than older technology based on deuterated triglycine sulfate (DTGS) detector elements.

Element size is reported in terms of diameter (mm) for circular detector elements, or area (mm²), with x, y dimensions for quadrangular shaped elements. Ideally, systems are designed to match the beam diameter and detector element size - not over-filling or under-filling the detector element. A significantly over-filled detector element will not measure the full system flux and, consequentially, the signal-to-noise ratio will be diminished. This must be balanced with the fact that detector noise increases with increased detector area. To prevent saturation in high-D* detectors, reducing the beam intensity by reducing the beam diameter is not effective. Any area of the detector that is saturated will demonstrate saturation in the resulting spectrum. Figure 1 shows examples of an MCT-A, DLaTGS (with Validation Wheel option) and InGaAs detectors.



Figure 1: Vibrational spectroscopy detectors use a pre-aligned, pinned-inplace design and may be repositioned to other system locations with automatic recognition



Detector Element/Window	Element Size	Spectral Range	Typical D* cm Hz ^{1/2} W ⁻¹	Minimum Responsivity	Operating Temperature	Typical Preamplifie Bandwidtl
lid-infrared						
DLaTGS/KBr	1.3 mm	12500-350 cm ⁻¹	2.7 E8	50 V/W	Room temp.	75 kHz
DLaTGS/KBr	1.3 mm	12500-350 cm ⁻¹	2.7 E8	50 V/W	TE cooled	75 kHz
DLaTGS/Csl	1.3 mm	6400-200 cm ⁻¹	2.4 E8	50 V/W	Room temp.	75 kHz
LiTaO ₃ /KBr	1.5 mm	10000-400 cm ⁻¹	1.0 E8	20 V/W	Room temp.	75 kHz
MCT-A*/CdTe	1.0 x 1.0 mm ²	11700-800 cm ⁻¹	6.4 E10	1,200 V/W	Liquid N ₂	175 kHz
MCT-A/CdTe	1.0 x 1.0 mm ²	11700-600 cm ⁻¹	4.7 E10	750 V/W	Liquid N ₂	175 kHz
MCT-B/KRS-5	1.0 x 1.0 mm ²	11700-400 cm ⁻¹	4.7 E10 8.0 E9	50 V/W	Liquid N ₂	175 kHz
			0.0 20		Liquid HZ	
lear-infrared						
InGaAs/glass	1.0 mm	12000-3800 cm ⁻¹	4.4 E10	1.3 A/W	Room temp.	170 kHz
InGaAs/glass	1.0 mm	12000-3800 cm ⁻¹	3.0 E11	1.4 A/W	TE cooled	50 kHz
PbSe/sapphire	1.0 x 1.0 mm ²	11000-2000 cm ⁻¹	2.5 E9	6,000 V/W	Room temp.	100 kHz
InSb/CdTe	2.0 x 2.0 mm ²	10000-1850 cm ⁻¹	2.2 E11	2.2 A/W	Liquid N ₂	250 kHz
isible						
Si/Quartz	2.5 mm	27000-8600 cm ⁻¹	2.8 E12	0.4 A/W	Room temp.	170 kHz
DLaTGS/Quartz	1.3 mm	25000-2000 cm ⁻¹	2.7 E8	50 V/W	Room temp.	170 kHz
ar-infrared		700 50 1	4.0.50	000 \/ \\		45.111
DLaTGS/Poly	1.5 x 1.5 mm ²	700-50 cm ⁻¹	4.8 E8	300 V/W	Room temp.	15 kHz
Si/Teflon®	2.5 x 2.5 mm ²	600-20 cm ⁻¹	1.6 E12	170,000 V/W	Liquid He	1 Hz
R Microscope						
MCT-A*/CdTe	0.05 x 0.05 mm ²	11700-700 cm ⁻¹	6.4 E10	60,000 V/W	Liquid N ₂	175 kHz
MCT-A*/CdTe	0.25 x 0.25 mm ²	11700-750 cm ⁻¹	6.4 E10	7,000V/W	Liquid N ₂	175 kHz
MCT-A/CdTe	0.25 x 0.25 mm ²	11700-600 cm ⁻¹	4.7 E10	6,500 V/W	Liquid N ₂	175 kHz
MCT-B/KRS-5	0.25 x 0.25 mm ²	11700-450 cm ⁻¹	8.0 E9	400 V/W	Liquid N ₂	175 kHz
InGaAs/glass	0.30 mm	12000-3800 cm ⁻¹	3.0 E12	1.0 A/W	TE cooled	50 kHz
T-Raman	1.0		10 540		De en l'	4
InGaAs/glass	1.0 mm	3600-100 R. shift	1.0 E12	.95 A/W	Room temp.	1 kHz
Ge/glass	3.0 mm	3600-100 R. shift	5.0 E13	.70 A/W	Liquid N ₂	2 kHz
AS						
Photoacoustic	8 mm	4000-100 cm ⁻¹	2.0 E7	5 V/W	Room temp.	30 kHz
RC						
RS MCT-A/CdTe	1.0 x 1.0 mm ²	11700-600 cm⁻¹	4.0 E10	6.0 A/W	Liquid N ₂	20 MHz

Table 1: Vibrational spectroscopy detector specifications. These specifications are subject to change based upon technological advancement. Please contact your local Thermo Scientific representative for more information.

The spectral ranges for different detectors listed in Table 1 are reported as the endpoints where spectral response begins and ends, and can be diminished based upon specific experimental conditions. Reported values are generated from the combination of detector element responsivity and window material composition. Measured response will be dependent upon the choice of beamsplitter and source and the optics of any sampling accessory used.

Specific D* is a measure of the detector signal as a function of energy flux and detector noise. At low-light levels, the D* number may be directly compared from one detector type to another. For example, the MCT-A* detector with a D* of 6.4×10^{10} is over 200 times more sensitive than the DLaTGS detector with a D* of 2.7×10^{8} . It is important to consider that detectors with high D* values tend to demonstrate saturation effects in high-throughput experiments. In this case, a neutral-density screen may be used to reduce energy flux at the detector.

D* is proportional to the signal from the detector relative to the energy flux reaching the detector. This means that a higher D* detector can provide higher response in a low energy flux environment. D* accounts for detector noise, so selecting a high D* detector can provide a higher signal and lower noise.

Figure 2 shows a graphical representation of D* and the spectral range for the detectors. This figure can be used to graphically compare detector D* and spectral range for most of the detector products.

Another measure of detector performance is responsivity (R_y), which is a measure of the detector signal per energy flux and detector area. A higher value of R_y indicates a higher detector response for a given energy flux and is corrected for detector area. Note that R_y does not consider detector noise. However, responsivity is a good measure of detector response where signal is sufficient such that noise is not observed. Many FT-IR detectors operate at room temperature while others require cooling with liquid nitrogen (77 K) for example. Thermo Scientific electric cooling (TE or Peltier cooling) provides enhanced, 100% line stability for the DLaTGS detector, minimizing response changes due to changes in room temperature. For indium gallium arsenide (InGaAs) detectors, cooling can provide increased performance at very low-light levels. TE cooling for DLaTGS improves stability, but not D*; cooling quantum detectors improves D*.

Our detectors cooled by liquid nitrogen utilize a patented, stainless steel dewar, which provides a liquid nitrogen hold time of 18 hours (U.S. Patent 4,740,702). This extended hold time is useful for long experiments such as microscope mapping and extended kinetic measurements. This proprietary detector design also eliminates the formation of ice on the MCT element, thereby preventing spectral artifacts due to water absorption.

Generally, higher bandwidths are required for fast, data-collection applications, such as rapid-scan analysis and time-resolved spectroscopy (TRS).

We offer a wide variety of detectors to optimize each FT-IR experiment and sampling condition. This document provides a reference of general sensitivity, responsivity, and spectral range information for most of the detectors. It clearly demonstrates a wide variety of choices with which you can configure an instrument to precisely meet your needs. It is intended as a general reference for standard versions of the detector products. If you have questions or comments about a detector not shown here, or a special requirement, please contact your local Thermo Scientific representative.

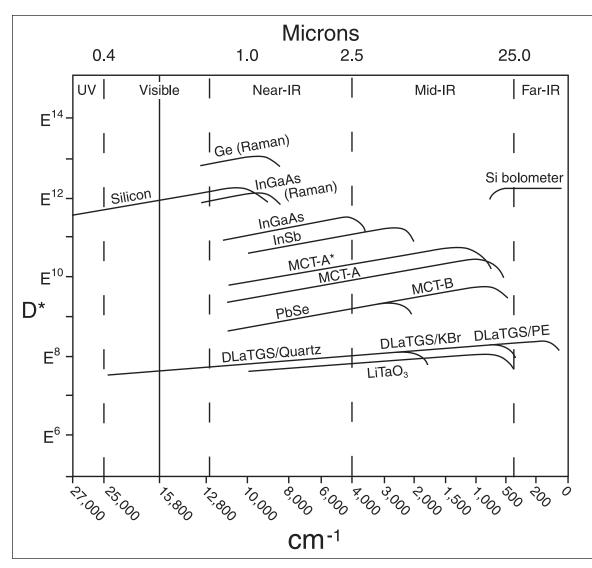


Figure 2: Graphical representation of detector D* versus spectral range for Nicolet FT-IR detectors. The vertical line at 15798 cm⁻¹ represents the helium neon (HeNe) laser emission band which is utilized for internal registration of spectral data.

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